

<b>Notice of References Cited</b>	Application/Control No. 10/725,470	Applicant(s)/Patent Under Reexamination ONO, KENICHI	
	Examiner Hai C. Pham	Art Unit 2861	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,926,616	07-1999	Sato et al.	358/1.2
*	B	US-4,926,268	05-1990	Kawamura et al.	358/3.1
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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